
Maelstrom Documentation

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Contents

1	<code>maelstrom.heat</code>	3
2	<code>maelstrom.maxwell</code>	5
3	<code>maelstrom.stokes</code>	7
4	<code>maelstrom.navier_stokes</code>	9
5	References	11
6	Indices and tables	13
	Bibliography	15

Relevant publications are [\[KP03\]](#), [\[DAG89\]](#), [\[Chu08\]](#), [\[vdV03\]](#), [\[GMS06\]](#), [\[DDKS12\]](#).

CHAPTER 1

maelstrom.heat

CHAPTER 2

maelstrom.maxwell

CHAPTER 3

maelstrom.stokes

CHAPTER 4

`maelstrom.navier_stokes`

CHAPTER 5

References

CHAPTER 6

Indices and tables

- `genindex`
- `modindex`
- `search`

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